# Equipment Information Sheet SUSS MJB4 Contact Aligner

Manager: Garry Bordonaro 607-254-4936 Backup: Giovanni Sartorello 607-254-4853 Backup: Michael Skvarla 607-254-4674

Calls to staff phones will be automatically forwarded to their cell phones during accessible hours. At other times leave a message or send them an email.

### **SAFETY**

- Orange UV glasses are recommended during exposure, but not required.
- Training by CNF staff is required prior to tool usage.

## **USAGE RESTRICTIONS**

• No buddy system restriction imposed on normal operation

#### SCHEDULING/SIGN-UP RESTRICTIONS

- Maximum 4 hour block reservation anytime
- No consecutive research group reservations
- Additional individual restriction my be imposed to maximized use

### MATERIALS COMPATIBILITY CATEGORY

#### **Tool Category 5: Class A and B Metals and Compounds**

Allowed	Not Allowed
Tool category 1/1E, 2, 3, and 4 materials	
Silicon Based Substrates and Films	
III/V compound Semiconductors	
Glass Substrates	
PECVD and ALD Films	
Cured organics and baked Photoresist	
CNF Class A, B, and Refractory metals	
Exposed Gold, Silver, Copper	
Alkali and Alkaline Compounds	
Organic/Biology Molecules prepared- w/salt buffers	
High Vapor Pressure Materials (Mg, Ca, Zn)*	* Some tool restrictions on high vapor pressure materials may apply
Soft organic materials	

# High Vapor Pressure Metals and Compounds are materials that have a vapor pressure above 1e-6 Torr at 400 C.

### **Additional Material Restrictions and Exceptions**

- 5" Mask size
- Substrate size from about 5mm square to 100mm in diameter.
- Backside of the substrate must be clean. No wet Resist.

Last Updated: 03/20/2025

Minimum Tool Time: 0 minutes